



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Komandur et al.	Group Art Unit: Not yet assigned Examiner: Not yet assigned Docket: NT-257C1-US
Serial No.: 10/697,199	
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Title: Distributed Control System For Semiconductor Manufacturing Equipment	

INFORMATION DISCLOSURE STATEMENT

US PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant	
MM	AA	6,368,880	April, 2002	Singhvi et al.	In Serial No. 10/199,924
	AB	6,251,759	June, 2001	Guo et al.	In Serial No. 10/199,924
	AC	6,224,638	May, 2001	Jevtic et al.	In Serial No. 10/199,924
	AD	6,136,163	Oct., 2000	Cheung et al.	In Serial No. 10/264,726
	AE	6,110,011	Aug., 2000	Somekh et al.	In Serial No. 10/264,726
	AF	5,972,110	Oct., 1999	Akimoto	In Serial No. 10/264,726
↓	AG	5,885,138	March, 1999	Okumura et al.	In Serial No. 10/264,726
↓	AH	5,826,129	Oct., 1998	Hasebe et al.	In Serial No. 10/264,726

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Examiner Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant		
MM	AI	WO 200229861	April, 2002	Morad et al.	In Serial No. 10/199,924	
↓	AJ	EP 1037263	Sep., 2000	Cheung et al.	In Serial No. 10/264,726	
↓	AK	EP 0978867	Feb., 2000	Moto et al.	In Serial No. 10/264,726	

OTHER DOCUMENTS

Examiner Initials	Cite No.					Trans-lation
X	X	X	X	X	X	X

Examiner Signature	KAPLA MOOPE	Date Considered	4/21/05
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